

Form PTO-1449 (Modified)	Atty Docket No.: E0802	Serial No.: 09/729,513
<p align="center">LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)</p>		
Applicant: Yedur, <i>et al.</i>		
Filing Date: 12/04/00	Group: Unknown	

REFERENCE DESIGNATOR U.S. PATENT DOCUMENTS

Examiner Initial		Document Number								Date	Name	Class	Subclass	Filing Date if Appropriate
KF	AA	4	8	9	6	0	4	4		01/23/90	Li, <i>et al.</i>			
KF	AB	5	6	1	8	7	6	0		04/08/97	Soh, <i>et al.</i>			
KF	AC	5	9	6	6	6	7	7		10/12/99	Fiekowsky			
KF	AD	6	0	0	0	9	4	7		12/14/99	Minne, <i>et al.</i>			
	AE													
	AF													

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number								Date	Country	Class	Subclass	Translation	
														Yes	No
	AG														

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

KF	AH	Mango, R. and Bennett, B.R.; "Nanostructure Patterns Written in III-V Semiconductors by an Atomic Force Microscope", <u>Applied Physics</u> ; April 7 1997, American Institute of Physics, vol. 70, no. 14, p. 1855-1857
KF	AI	Sugimura, H., <i>et al.</i> , "Maskless Patterning of Silicon Surface Based on Scanning Tunneling Microscope Tip-Induced Anodization and Chemical Etching", <u>Applied Physics</u> ; September 19, 1994, American Institute of Physics, vol. 65, no. 12, p. 1569-1571.
EXAMINER		DATE CONSIDERED
5-29-03		KF

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.